INFORMATION DISCLOSURE STATEMENT BY AFFICANT Sheet 1 of 3  JUN 2 7 2003		Application Numl Filing Date: First Named Inve Group Art Unit: Examiner Name: Attorney Docket	August 11, 20 entor: Hiroji HANAV 1753 Rodney McĎ	09/638,075 August 11, 2000 Hiroji HANAWA, et al. 1753 Rodney McDonald 4609 M		ARCENED TO	
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Date Considered:

August 11, 2000
Hiroji HANAWA, et al.

No. To the second s **Application Number:** INFORMATION Filing Date: DISCLOSURE First Named Inventor: STATEMENT BY APPROCES Group Art Unit: Sheet 2 of 3 **Examiner Name:** JUN 2 7 2003 Attorney Docket Number: U. S. PATENT DOCUMENTS **Publication Date** Examiner Document No Name of Patentee or Initials Applicant of Cited Document 10 09-03-1985 **FARLEY** 427 06-27-84 US-4,539,217 186 US-4,565,588 01-21-1986 SEKLET AL. 148 10-10-84 437 US-4,698,104 10-06-1987 BARKER ET AL. 141 03-02-87 CONRAD 38 US-4,764,394 08-16-1988 427 01-20-87 US-4,912,065 03-27-1990 MIZUNO ET AL. 437 141 05-26-88 US-4,937,205 06-26-1990 NAKAYAMA ET AL. 437 165 06-26-90 US-5,270,250 12-14-1993 MURAI ET AL. 437 165 12-23-91 US-5,354,381 10-11-1994 SHENG 118 723 05-07-93 US-5,514,603 05-07-1996 SATO 437 16 05-06-94 US-5.561.072 01-01-1996 SAITO 437 24 11-21-94 US-5,654,043 08-05-1997 SHAO ET AL. 427 527 10-10-96 US-5,572,038 11-05-1996 SHENG ET AL. 250 492.21 05-07-93 US-5,711,182 01-27-1998 CHAPEK ET AL. 118 723 06-06-95 US-5,911,832 06-15-1999 DENHOLM ET AL. 118 723 01-09-97 US-6,020,592 02-01-2000 LIEBERT ET AL. 250 492.21 08-03-98 US-6,050,218 04-18-2000 CHEN ET AL. 118 723 09-28-98 US-6,101,971 08-15-2000 DENHOLM ET AL. 118 723 12-22-98 FOREIGN PATENT DOCUMENTS Examiner Foreign Patent **Publication Date** Country Name of Patentee or Applicant of Cited Translation? Initials Document **Document** (Yes/No/n/a) Examiner NON PATENT LITERATURE DOCUMENTS Initials

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Filing Date:

First Named Inventor: Group Art Unit:

Examiner Name:

)9/638,075 August 11, 2000 Hiroji HANAWA, et al. 2000 1753

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**INFORMATION DISCLOSURE** STATEMENT BY APPLICA

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Application Number:

Filing Date:

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First Named Inventor:

Group Art Unit: Examiner Name: Attorney Docket Number: 09/638,075

August 11, 2000 Hiroji HANAWA, et al.

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Rodney McDonald

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Application Number:

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First Named Inventor: Group Art Unit:

Examiner Name: Attorney Docket Number: 09/638,075 August 11, 2000

Hiroji HANAWA, et al.

Rodney McDonald

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Application Number:

Filing Date:

09/638,075 August 11, 2000 Hiroji HANAWA, et al.

First Named Inventor: Group Art Unit: Examiner Name:

1763 Rodney McDonald

Attorney Docket Number:

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Sheet 4 of 7

Application Number:

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First Named Inventor: Group Art Unit:

09/638,075 August 11, 2000 Hiroji HANAWA, et al.

1763

Examiner Name:

Rodney McDonald

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Hiroji HANAWA, et al. 1763

09/638,075

Group Art Unit: Examiner Name:

Rodney McDonald

August 11, 2000

Attorney Docket Number: 004609

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Group Art Unit:

1763

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